



BSI Standards Publication

Device embedding assembly technology

Part 2-8: Guidelines — Warpage control of active device embedded substrate

National foreword

This Published Document is the UK implementation of IEC TR 62878-2-8:2021.

The UK participation in its preparation was entrusted to Technical Committee EPL/501, Electronic Assembly Technology.

A list of organizations represented on this committee can be obtained on request to its committee manager.

Contractual and legal considerations

This publication has been prepared in good faith, however no representation, warranty, assurance or undertaking (express or implied) is or will be made, and no responsibility or liability is or will be accepted by BSI in relation to the adequacy, accuracy, completeness or reasonableness of this publication. All and any such responsibility and liability is expressly disclaimed to the full extent permitted by the law.

This publication is provided as is, and is to be used at the recipient's own risk.

The recipient is advised to consider seeking professional guidance with respect to its use of this publication.

This publication is not intended to constitute a contract. Users are responsible for its correct application.

This publication is not to be regarded as a British Standard.

© The British Standards Institution 2021
Published by BSI Standards Limited 2021

ISBN 978 0 539 13658 6

ICS 31.180; 31.190

Compliance with a Published Document cannot confer immunity from legal obligations.

This Published Document was published under the authority of the Standards Policy and Strategy Committee on 31 August 2021.

Amendments/corrigenda issued since publication

Date	Text affected
------	---------------



TECHNICAL REPORT



**Device embedding assembly technology –
Part 2-8: Guidelines – Warpage control of active device embedded substrate**

INTERNATIONAL
ELECTROTECHNICAL
COMMISSION

ICS 31.180; 31.190

ISBN 978-2-8322-9953-1

Warning! Make sure that you obtained this publication from an authorized distributor.

CONTENTS

FOREWORD..... 3

1 Scope..... 5

2 Normative references 5

3 Terms and definitions 5

4 Warpage driving force and resistance..... 6

 4.1 General..... 6

 4.2 Warpage driving force..... 6

 4.3 Warpage resistance 6

 4.4 Determining parameters..... 7

5 Guideline for warpage of active device embedded substrate..... 9

 5.1 General..... 9

 5.2 Rigidity 9

 5.3 Neutral axis 9

 5.4 Typical example of low rigidity case 10

 5.5 Typical example of high rigidity case..... 11

6 Conclusion 13

Bibliography..... 14

Figure 1 – Warpage behaviour of device embedded substrate during heating and cooling..... 6

Figure 2 – Relationship between warpage and rigidity..... 7

Figure 3 – Parameters determining warpage..... 7

Figure 4 – Effects of dummy Cu design on warpage..... 8

Figure 5 – Neutral axis of device embedded substrate 9

Figure 6 – Warpage behaviour of active device embedded substrate during heating and cooling 10

Figure 7 – Measured and simulated warpage results of die embedded substrates with low rigidity 11

Figure 8 – Structure of die embedded package with high rigidity 12

Figure 9 – Simulated results on effect of die thickness on die embedded package warpage..... 12

INTERNATIONAL ELECTROTECHNICAL COMMISSION

DEVICE EMBEDDING ASSEMBLY TECHNOLOGY –**Part 2-8: Guidelines –
Warpage control of active device embedded substrate**

FOREWORD

- 1) The International Electrotechnical Commission (IEC) is a worldwide organization for standardization comprising all national electrotechnical committees (IEC National Committees). The object of IEC is to promote international co-operation on all questions concerning standardization in the electrical and electronic fields. To this end and in addition to other activities, IEC publishes International Standards, Technical Specifications, Technical Reports, Publicly Available Specifications (PAS) and Guides (hereafter referred to as "IEC Publication(s)"). Their preparation is entrusted to technical committees; any IEC National Committee interested in the subject dealt with may participate in this preparatory work. International, governmental and non-governmental organizations liaising with the IEC also participate in this preparation. IEC collaborates closely with the International Organization for Standardization (ISO) in accordance with conditions determined by agreement between the two organizations.
- 2) The formal decisions or agreements of IEC on technical matters express, as nearly as possible, an international consensus of opinion on the relevant subjects since each technical committee has representation from all interested IEC National Committees.
- 3) IEC Publications have the form of recommendations for international use and are accepted by IEC National Committees in that sense. While all reasonable efforts are made to ensure that the technical content of IEC Publications is accurate, IEC cannot be held responsible for the way in which they are used or for any misinterpretation by any end user.
- 4) In order to promote international uniformity, IEC National Committees undertake to apply IEC Publications transparently to the maximum extent possible in their national and regional publications. Any divergence between any IEC Publication and the corresponding national or regional publication shall be clearly indicated in the latter.
- 5) IEC itself does not provide any attestation of conformity. Independent certification bodies provide conformity assessment services and, in some areas, access to IEC marks of conformity. IEC is not responsible for any services carried out by independent certification bodies.
- 6) All users should ensure that they have the latest edition of this publication.
- 7) No liability shall attach to IEC or its directors, employees, servants or agents including individual experts and members of its technical committees and IEC National Committees for any personal injury, property damage or other damage of any nature whatsoever, whether direct or indirect, or for costs (including legal fees) and expenses arising out of the publication, use of, or reliance upon, this IEC Publication or any other IEC Publications.
- 8) Attention is drawn to the Normative references cited in this publication. Use of the referenced publications is indispensable for the correct application of this publication.
- 9) Attention is drawn to the possibility that some of the elements of this IEC Publication may be the subject of patent rights. IEC shall not be held responsible for identifying any or all such patent rights.

IEC TR 62878-2-8, which is a technical report, has been prepared by IEC technical committee 91: Electronics assembly technology.

The text of this Technical Report is based on the following documents:

Draft	Report on voting
91/1649/DTR	91/1721/RVDTR

Full information on the voting for its approval can be found in the report on voting indicated in the above table.

The language used for the development of this Technical Report is English.

This document was drafted in accordance with ISO/IEC Directives, Part 2, and developed in accordance with ISO/IEC Directives, Part 1 and ISO/IEC Directives, IEC Supplement, available at www.iec.ch/members_experts/refdocs. The main document types developed by IEC are described in greater detail at www.iec.ch/standardsdev/publications.

A list of all parts in the IEC 62878 series, published under the general title *Device embedding assembly technology*, can be found on the IEC website.

The committee has decided that the contents of this document will remain unchanged until the stability date indicated on the IEC website under webstore.iec.ch in the data related to the specific document. At this date, the document will be

- reconfirmed,
- withdrawn,
- replaced by a revised edition, or
- amended.

IMPORTANT – The 'colour inside' logo on the cover page of this publication indicates that it contains colours which are considered to be useful for the correct understanding of its contents. Users should therefore print this document using a colour printer.

DEVICE EMBEDDING ASSEMBLY TECHNOLOGY –

Part 2-8: Guidelines –

Warpage control of active device embedded substrate

1 Scope

This part of IEC 62878 describes a warpage control of active device embedded substrate along with parameters for determining warpage, which are useful during package assembly. Warpage results are explained using warpage driving force, resistance and neutral axis, for typical die embedded substrate, where the discrete active dies are placed in the core of substrate and interconnected to the substrate by direct Cu bonding. The same principles are applicable in other device embedded substrates. Even though the detailed structure of other device embedded substrates might be different, the origin and determination of the parameters of warpage are the same and thus the purpose of this report is to help engineers improve the warpage behaviours of their products by applying this principle.

2 Normative references

IEC 60194 (all parts), *Printed boards design, manufacture and assembly – Vocabulary*

3 Terms and definitions

For the purposes of this document, the terms and definitions given in IEC 60194 and the following apply.

ISO and IEC maintain terminological databases for use in standardization at the following addresses:

- IEC Electropedia: available at <http://www.electropedia.org/>
- ISO Online browsing platform: available at <http://www.iso.org/obp>

3.1

warpage

deviation from uniform flatness of the substrate for the range of thermal conditions experienced during the package to board assembly

Note 1 to entry: Warpage during board assembly can cause the device terminals to have open or short circuit connections after the reflow soldering operation. Certain package types, such as BGAs (ball grid arrays), have been found to be more susceptible to component warpage [1]¹.

Note 2 to entry: Package warpage depends on many factors including CTE mismatch between device constituents, assembly process, package design geometries, top and embedded die, substrate, etc. (x, y, & z). In addition, it can be related with use of IHS (integrated heat spreader), stiffener, or overmold (geometries and material choices include sealant/adhesives used), and other technology aspects of embedded design, embedded and external caps, use of GaA vs. SiO₂, etc.

¹ Numbers in square brackets refer to the Bibliography.